

# SバンドRFガンとレーザースーパーキャビティ開発

高エネルギー加速器研究機構, 浦川順治

はじめに、JASRI,東大,KEKはそれぞれ別々の手法と目標を持って、Photo-cathode RF Gunの研究開発を進めている。KEKは、Cs<sub>2</sub>Te Photo-cathode, 1.6 Cell S-band RF Gunを使い、高QEマルチバンチビーム生成に関する開発研究を行っている。一方、東大はカートリッジ方式のカソード導入により短パルスビーム生成に関する研究開発を進めている。また、JASRIは先端安定レーザーシステム開発により、低エミッタンス電子ビーム生成に関する研究開発を行い、それぞれ相補的な研究成果を得ている。ここでは以下の報告を行う。

1. Cs<sub>2</sub>Te Photo-cathode, 1.6 Cell S-band RF Gunによるマルチバンチ電子ビーム生成
2. レーザースーパーキャビティ開発の現状
3. X線生成実験
4. まとめ

# 1. Cs<sub>2</sub>Te Photo-cathode, 1.6 Cell S-band RF Gun によるマルチバンチ電子ビーム生成

平成17年度での開発状況

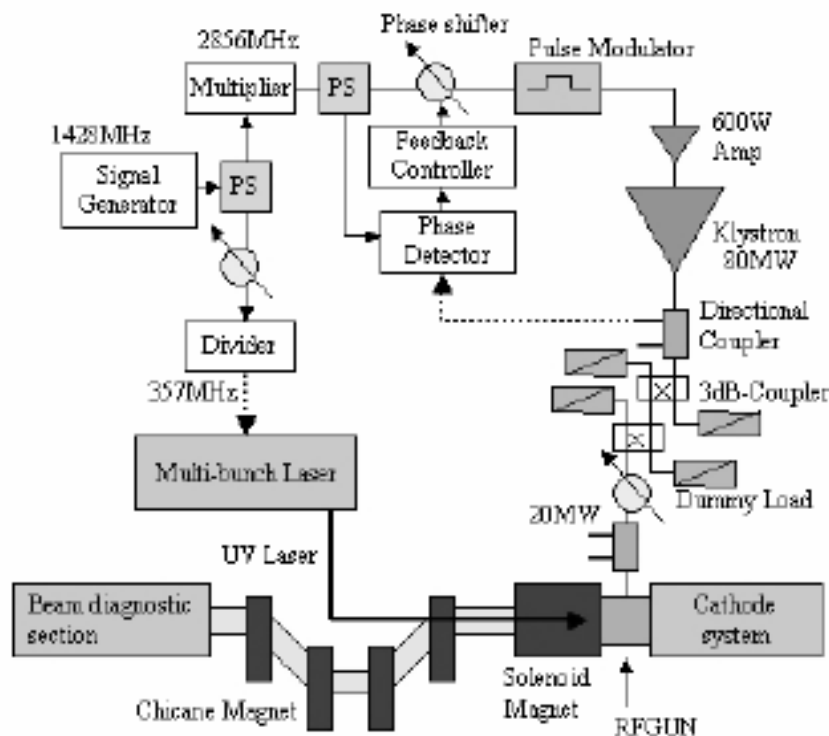


Figure 1: A schematic layout of the RFGTB

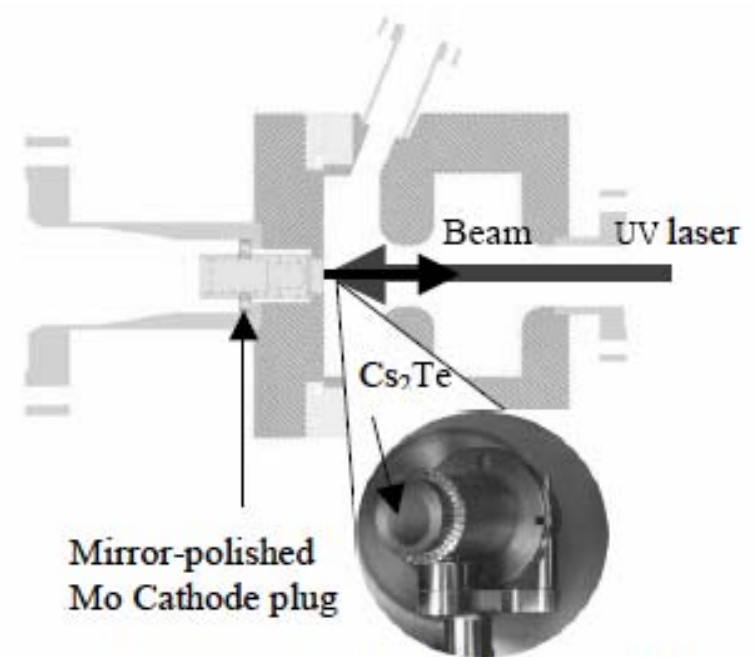


Figure 2: Cross section of the RF gun and the cathode plug.

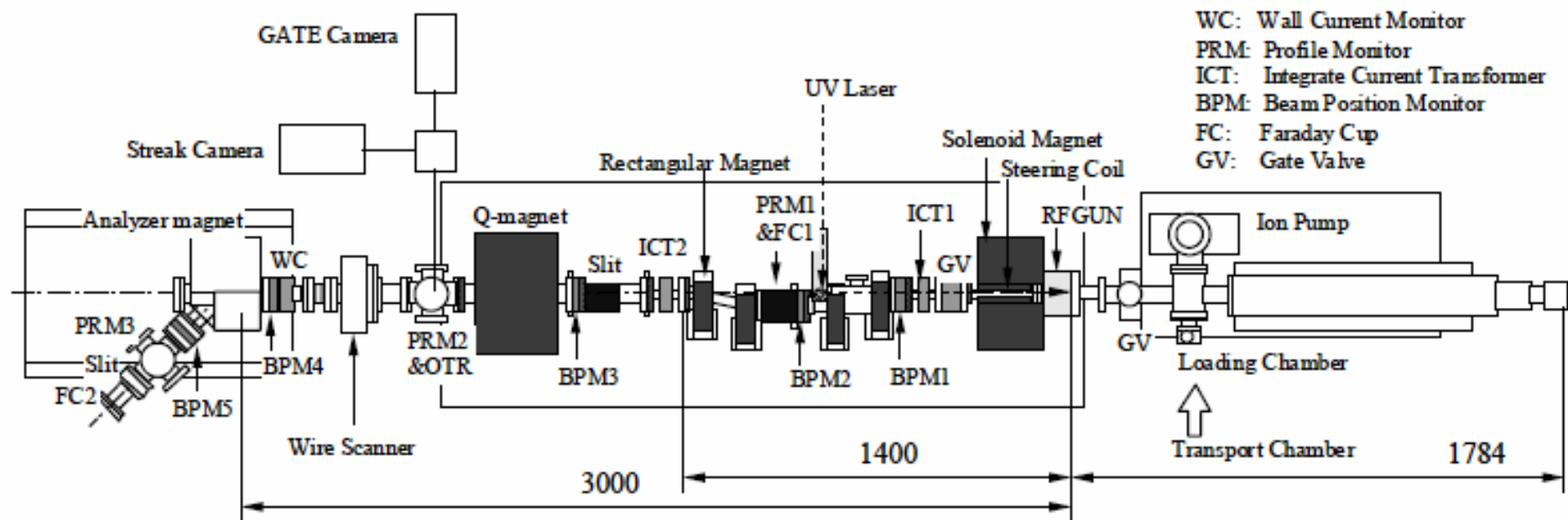


Figure 4: Schematic view of experimental setup

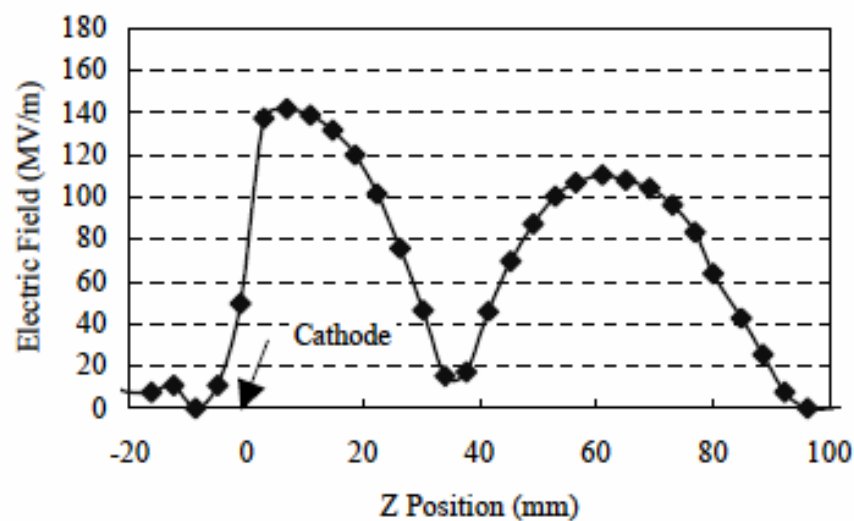


Figure 3: Electric field distribution in the RF gun cavity at the RF cavity power 15MW.

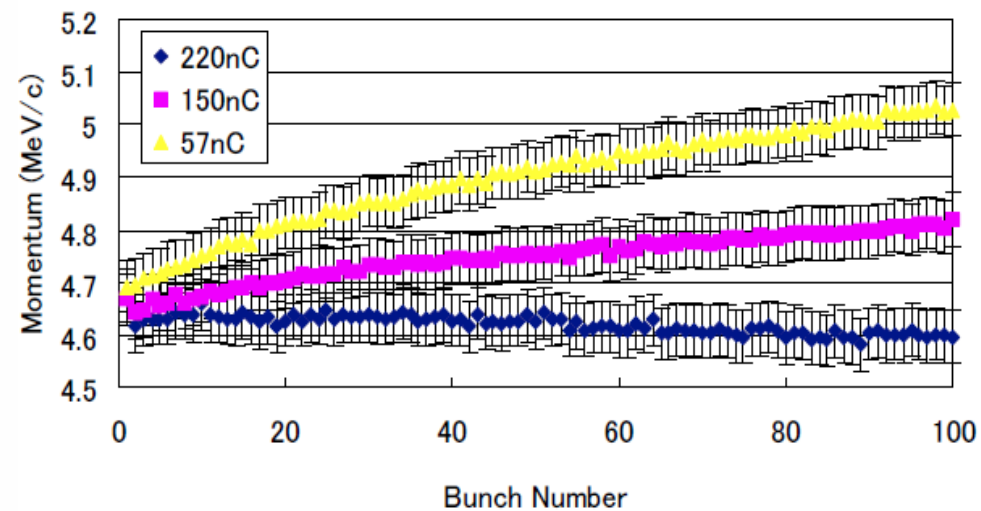
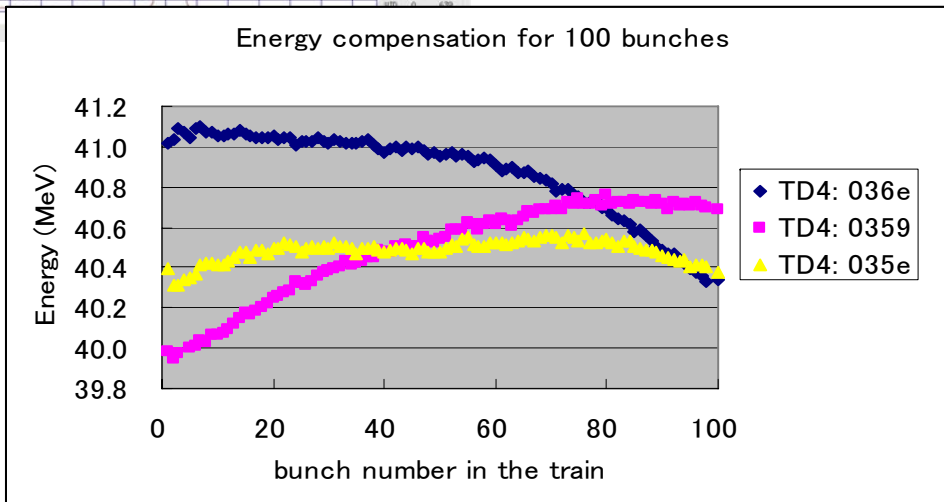
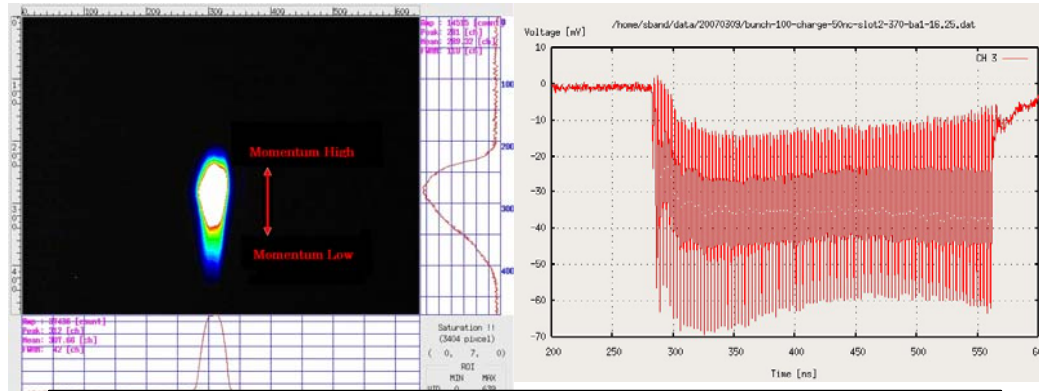
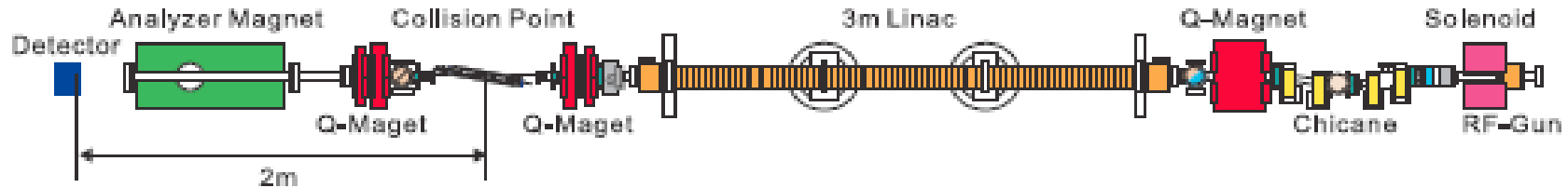


図5. 100 bunchesの運動量

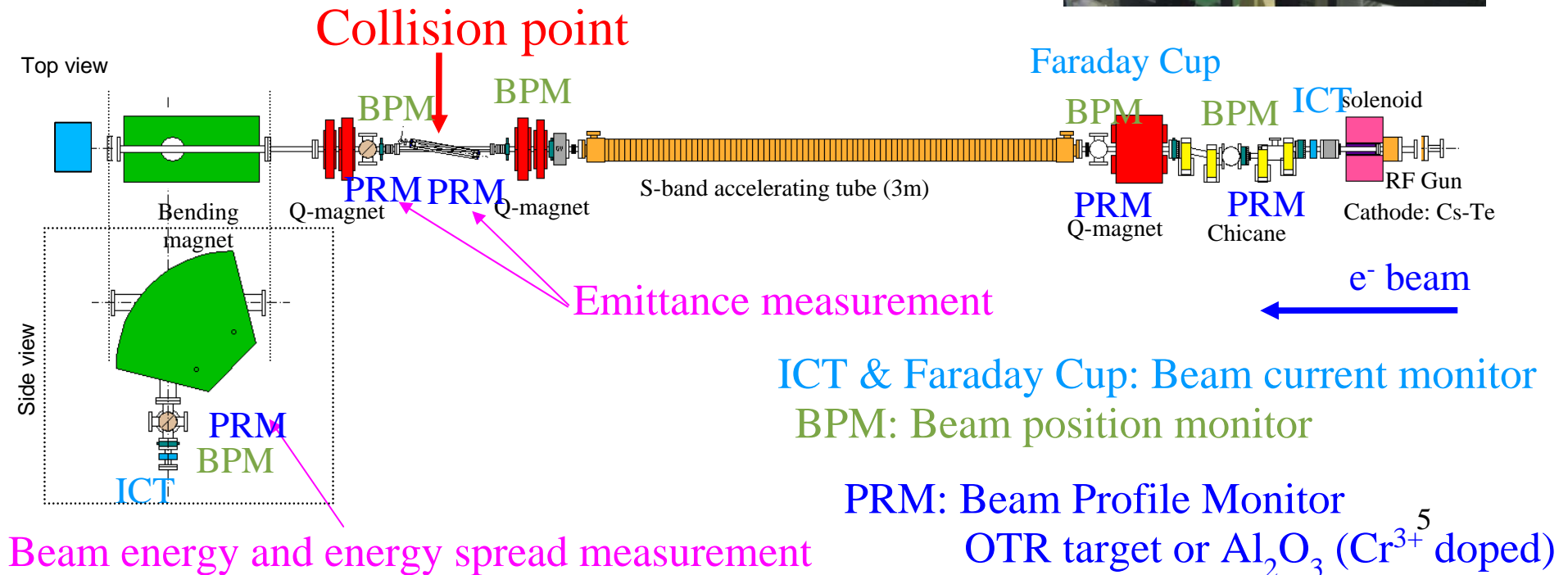
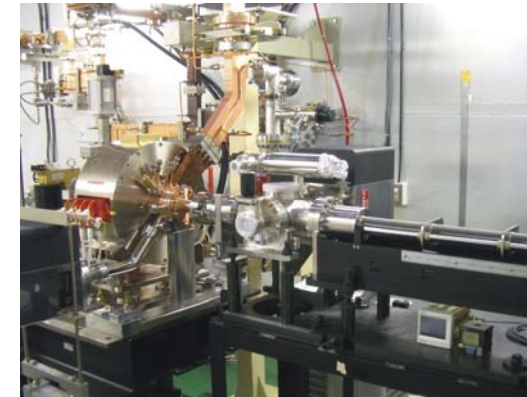
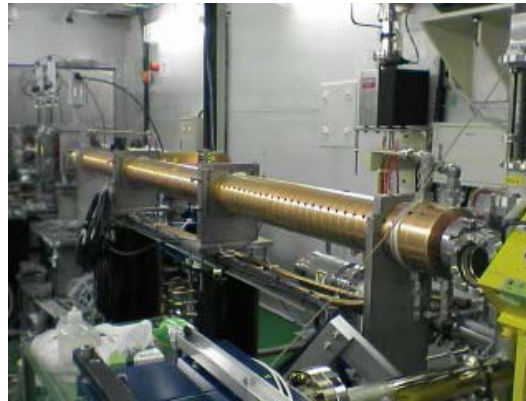
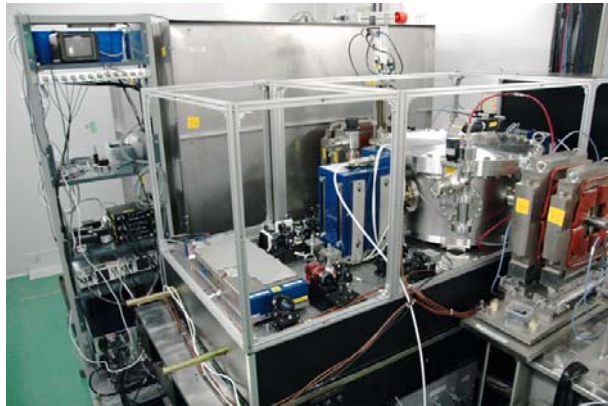
# 平成19年、現在40MeVマルチバンチ電子線型加速器完成



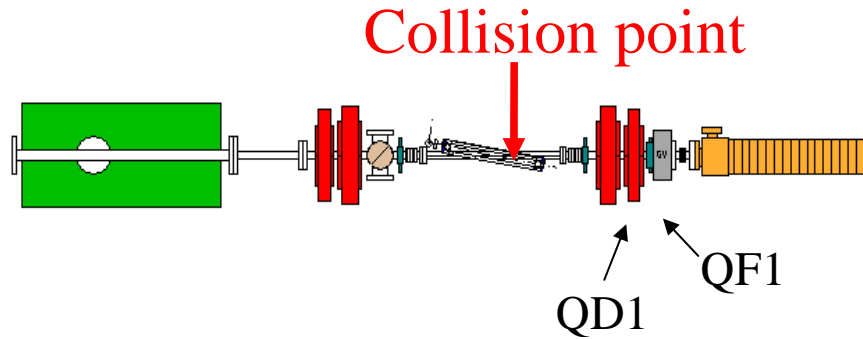
100 bunches/pulse energy spread is less than 0.5%.  
 問題点：S-band高周波源一台と高周波パルス圧縮装置を使用している為に50nC/100 bunches加速が限界である。12MWの高周波源を1台追加すれば、300nC/100bunchesを60MeVまで加速して、X線生成衝突に使える。

図7 Upper-left : ICT signal of 100 bunches, upper-right : 100 bunches on the OTR screen, bottom figure : energy of each bunch in the train

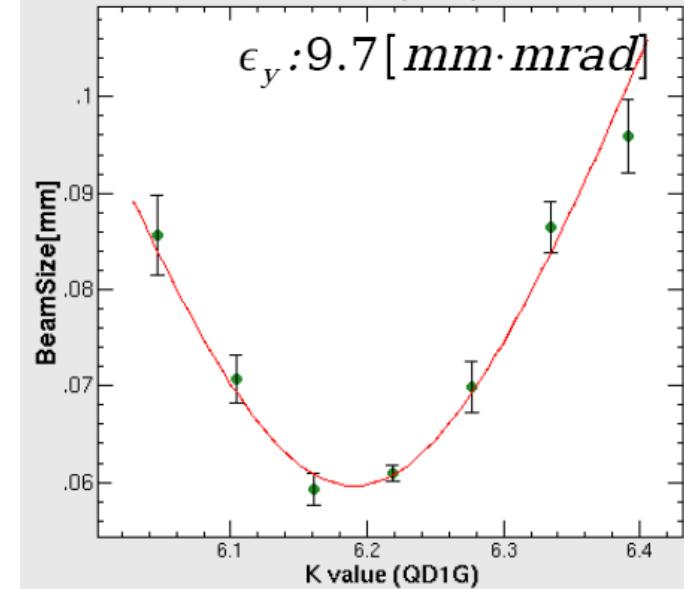
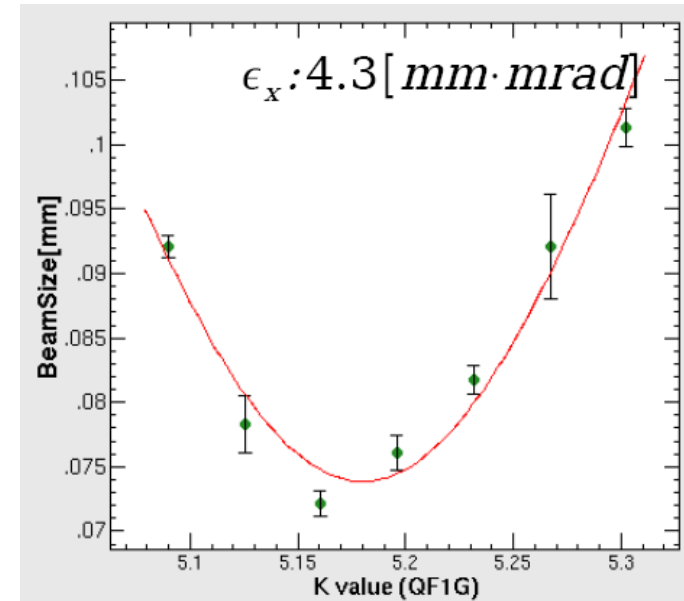
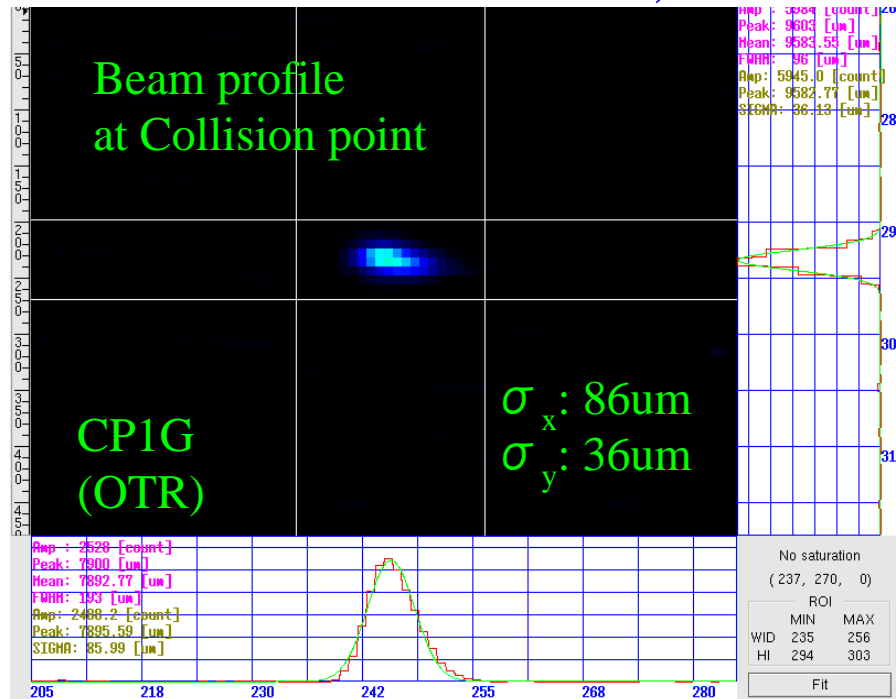
# Laser Pulse Stacking Chamber, 3m long S-band accelerating tube and Photo-cathode RF Gun



# Emittance measurement

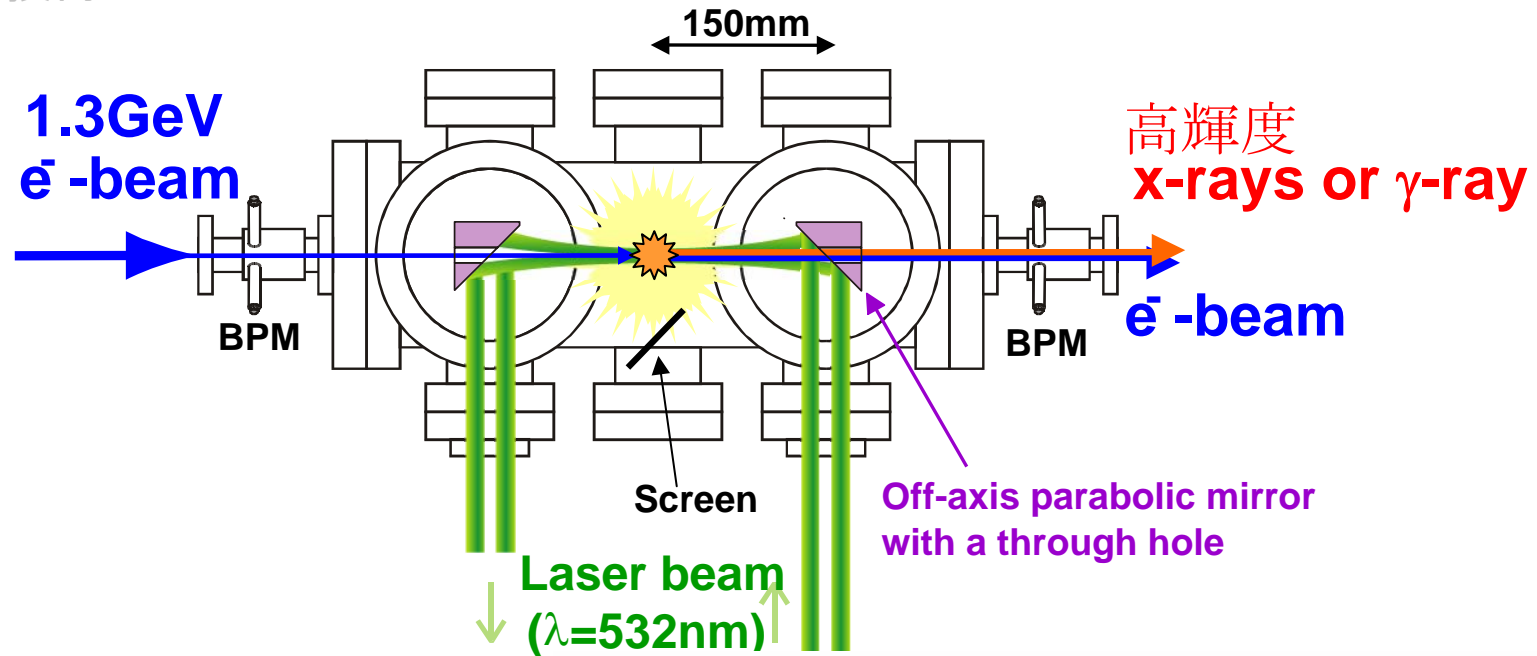


Beam current : 2.5nC/train, 5bunches



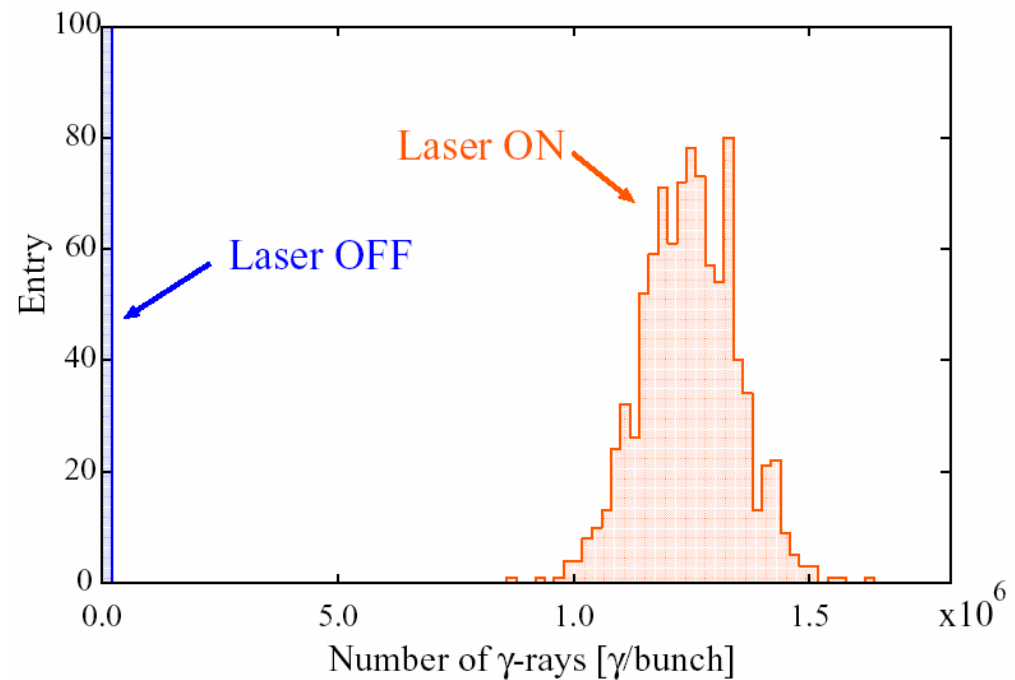


# 衝突技術: Head on collision



56 MeV Photon Beam  
Measured Number of  $\gamma$ -rays  
 $N_\gamma = (1.1 \pm 0.1) \times 10^6 / \text{bunch}$   
in 31 p sec

$N_\gamma = (2.1 \pm 0.1) \times 10^7 / \text{bunch}$   
This is highest result.



## 2. レーザースーパーキャビティ開発の現状

Laser:

Mode Lock: Passive

SESAM

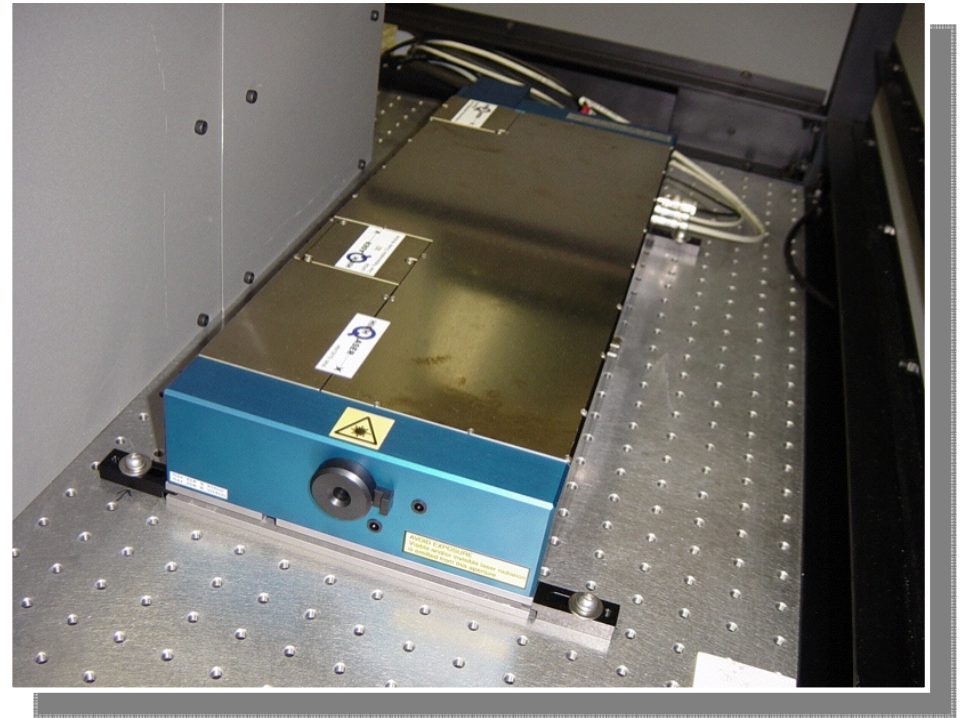
Frequency: 357MHz

Cavity length: 0.42 m

Pulse width: 7.3 p sec  
(FWHM)

Wave Length: 1064 nm

Power: ~ 6W

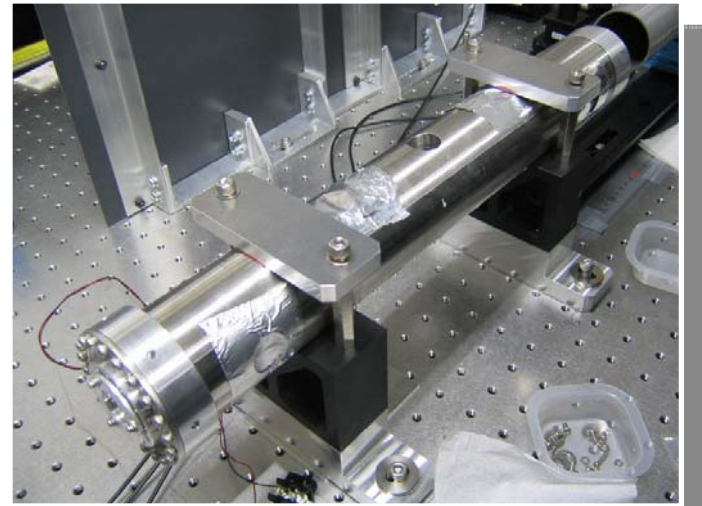


SESAM: SEmi-conductor Saturable Absorber Mirrors



## Ext. Cavity:

Cavity:	Super Invar
Cavity length:	0.42 m
Mirrors:	
Reflectivity:	99.7%, 99.9%
Curvature:	250 mm ( $\omega_0 = 180 \mu\text{m}$ )



High Power Test:  $R = 99.7\%$



Finesse = 1100

Cavity Transmission =  $P_{\text{out}}/P_{\text{in}} = 63\%$

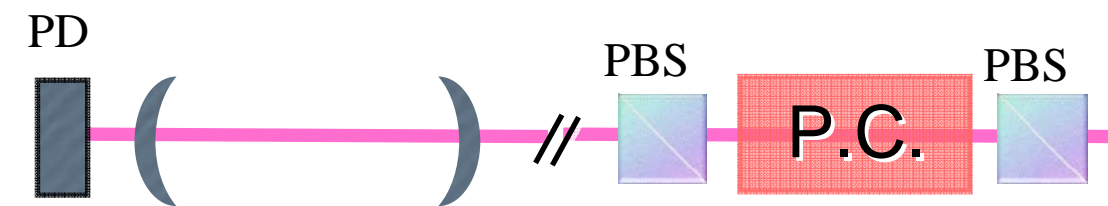
Enhancement Factor = 220

**$P(\text{cavity}) = 660\text{W} (1.8 \mu\text{J/Pulse})$**

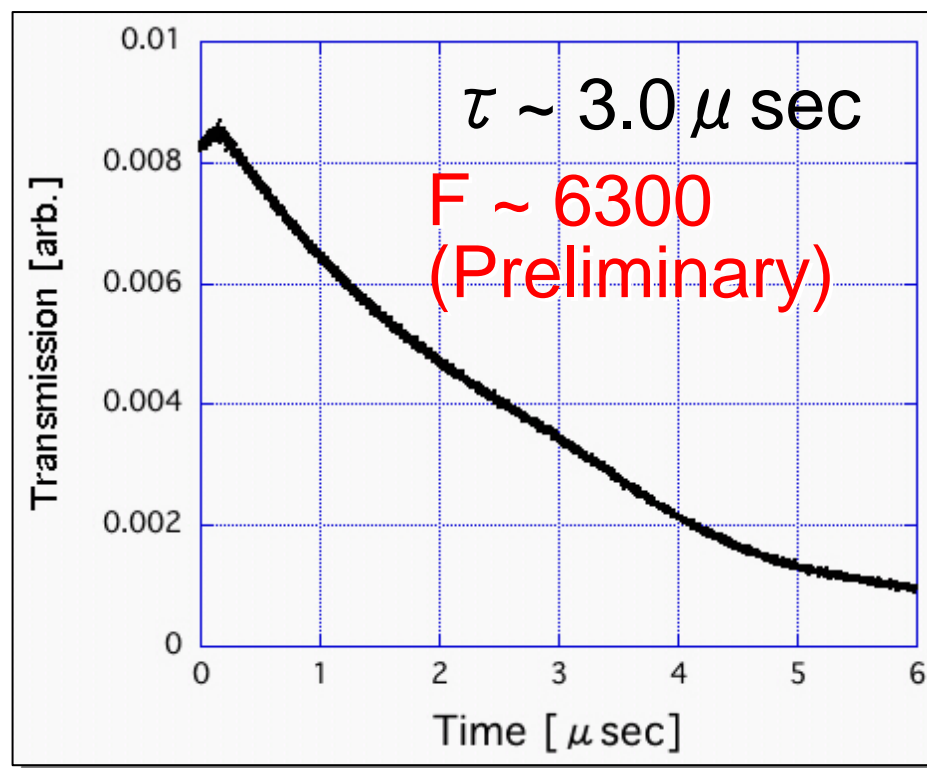
▪ Finesse:  $R = 99.9\%$

$$\text{Finesse} = \pi \tau c/l$$

$\tau$ : decay time  
 $c$ : light verocity  
 $l$ : cavity length



Trans.



3000倍以上  
期待値

# Required Spec. of Optical Resonator

## [ pulsed laser-wire ]

Initial Laser : >6W@357MHz

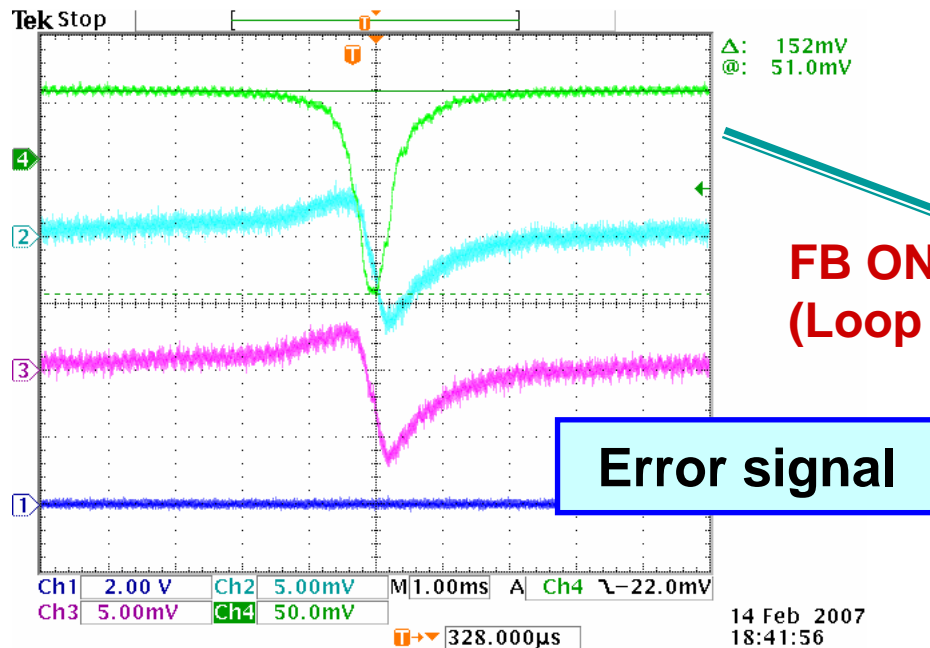
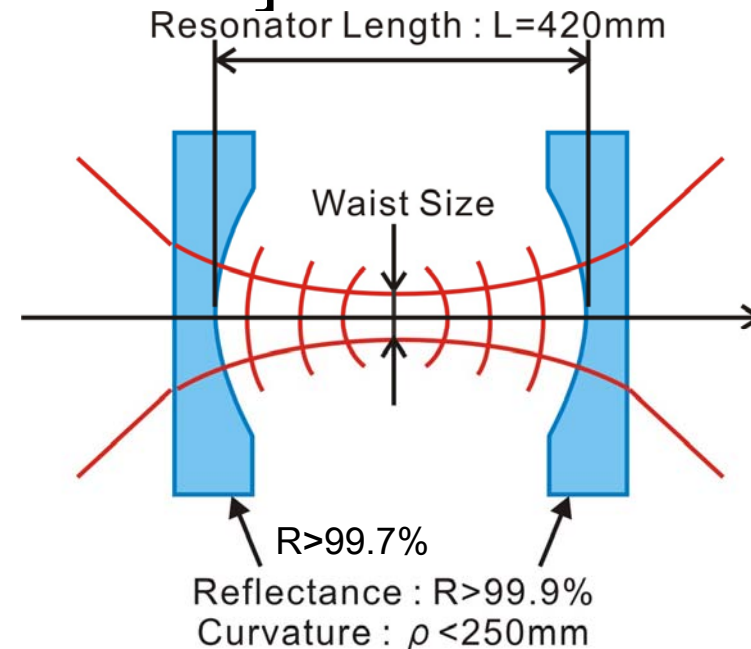
→ Cavity Length : 420mm

Beam Waist : <170um in  $2\sigma$

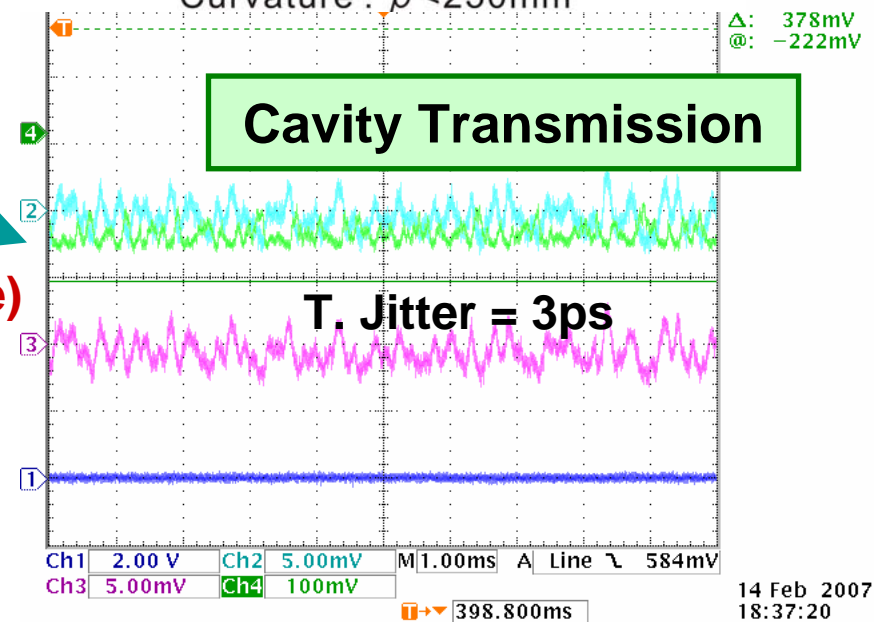
→ Mirror Curvature : <250mm

Finesse : >1550

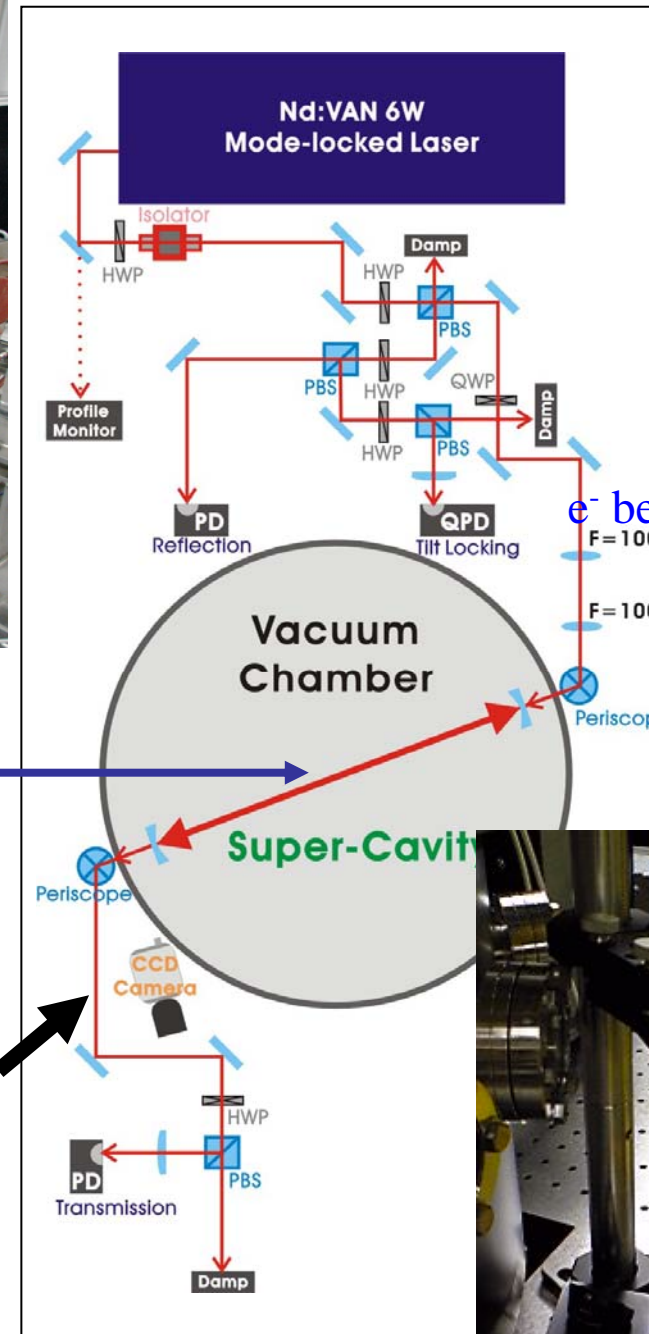
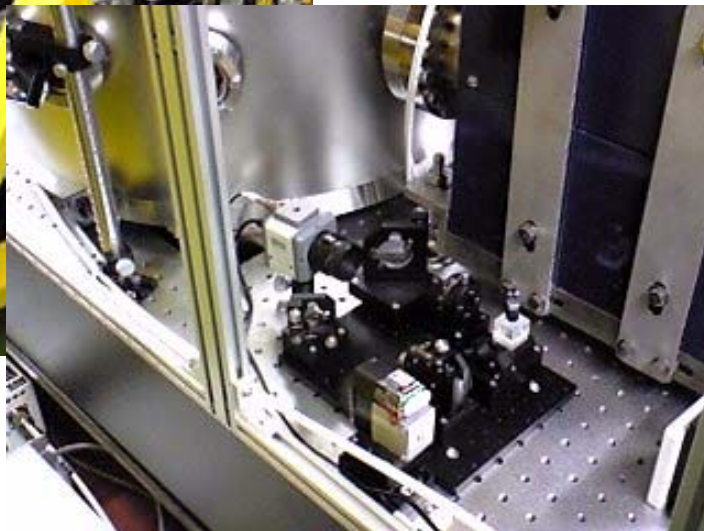
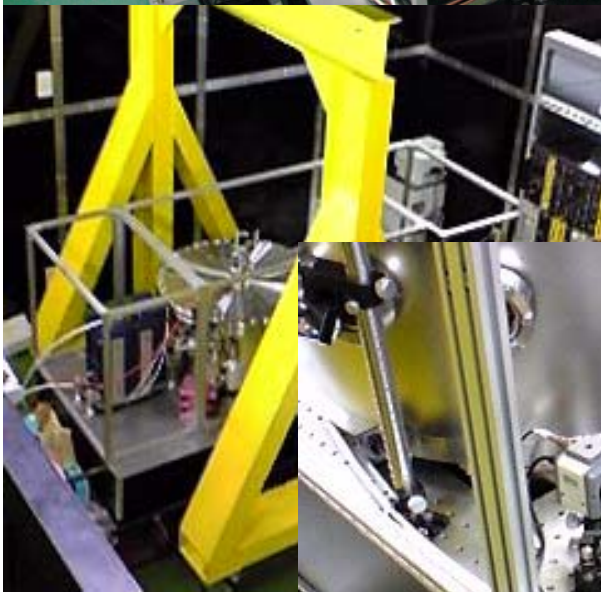
→ Mirror Reflectivity : 99.7%, 99.9%



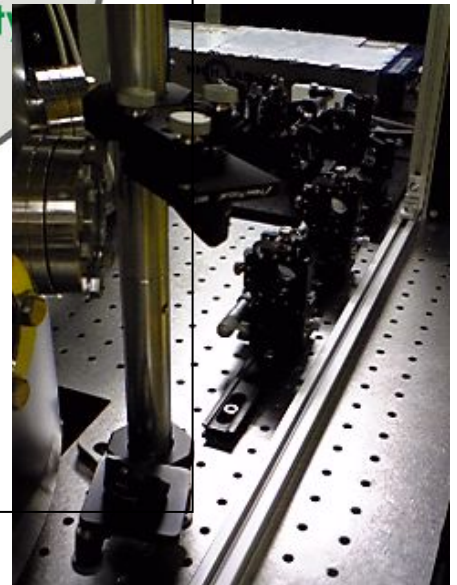
FB ON  
(Loop Close)







$e^-$  beam



最近の実験結果：加速器高周波ClockでMode-locking

Electron		Laser	
RF Rep.	12.5Hz	Crystal	Nd:VAN
Energy	40MeV	Wavelength	1064nm
Pulse Rep.	357MHz	Laser Freq.	357MHz
Bunch Num.	100/train	Enhancement	630
Charge	0.5nC/bunch	Power	2.45kW
Bunch length	20ps	Pulse width	7ps
Beam size	X:80 $\mu$ m	Waist size	X:89 $\mu$ m
	Y:40 $\mu$ m		Y:89 $\mu$ m
Collision angle	20degrees		

Transmittance of Input	Transmittance of Output	Finesse	Waist Size
0.221%	0.071%	1889.9	89.2 $\mu$ m

Input Power	Power in Cavity	Enhancement
4.05W	2.45kW	605

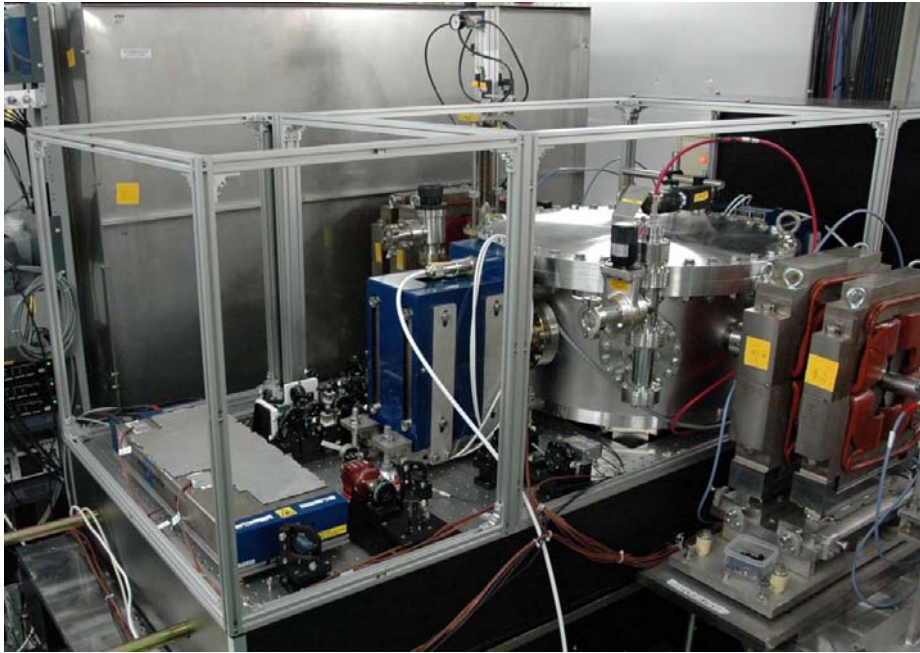
6.86 $\mu$ J/7ps  
達成。



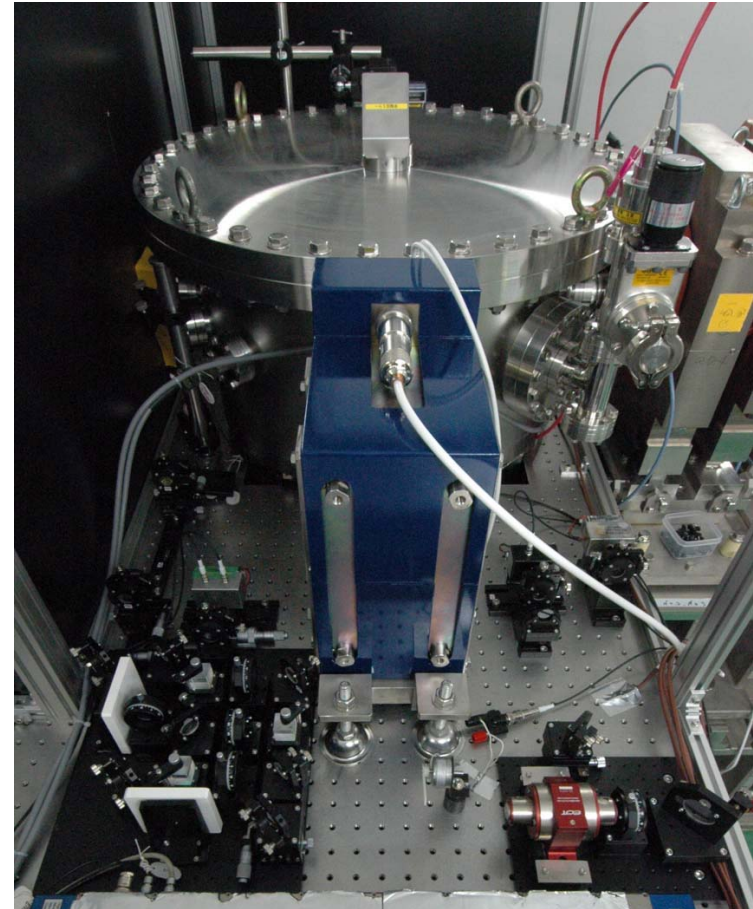
10mJ/7ps〜。



### 3. X線生成実験



43MeV end station to separate X-ray and e-beam. 33keV X-ray is deflected by Crystals.



Pulsed laser stacking chamber

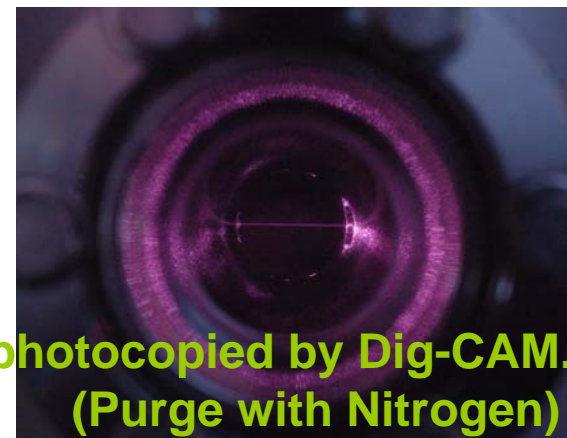
実験結果：3日間のX線  
検出実験を行ったが、30  
keV-X rayの信号確認は  
できなかった。何か見落  
としかがあると思われる。

コリメータを通過する生成X線のエネルギーと強度

コリメータ条件(受け入れ角)	X線エネルギーと強度
無し	1.16eV~32.7keV, $6.2 \times 10^5$ photons/sec
$1/\gamma(\pm 11.5\text{mrad})$	16.3~32.7keV, $3.2 \times 10^5$ photons/sec
$0.23/\gamma(\pm 2.64\text{mrad})$	31.1~32.7keV, $4.5 \times 10^4$ photons/sec

Frequency	Finesse	Waist Size ( $2\sigma$ )	Inject laser power	Laser power in resonator with FB
357 MHz	$1889 \pm 31.5$	$178.4 \pm 7.5 \mu\text{m}$	4.05 W @357 MHz	$2.40 \pm 0.05 \text{ kW}$

→ x 630



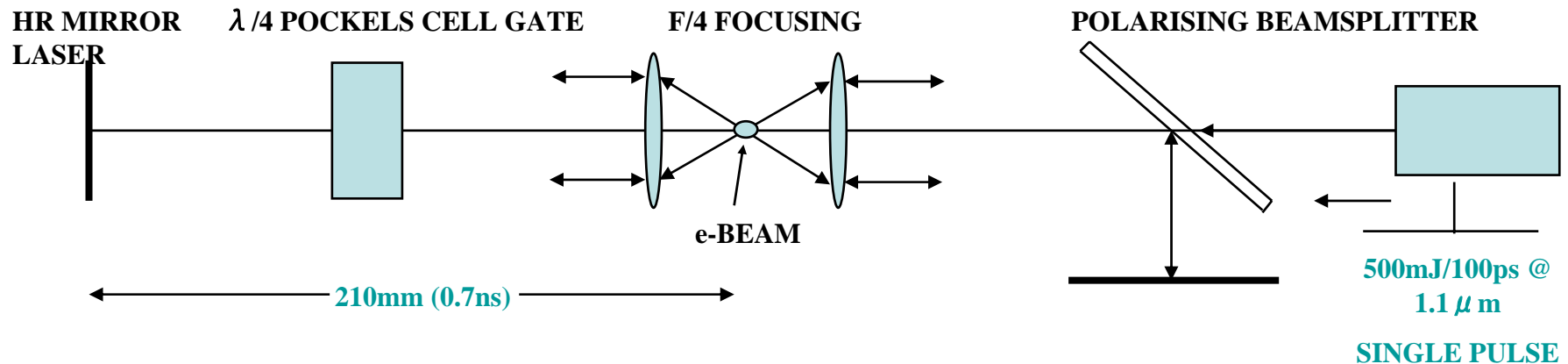
Inside of e-beam chamber was photocopied by Dig-CAM.  
(Purge with Nitrogen)

## まとめ(目標を述べる。)

1. X線生成実験を10月から再開して、S/Nの高い測定結果を得る。
2. レーザースーパーキャビティの増幅率を4000倍以上にする。
3. 電子ビームのさらなるマルチバンチ化により1000nC/pulseを達成する。
4. 十分なX線生成が可能であることを示す。

# Burst mode amplification or New Idea by UK (別グループに依頼)

## Use a Misaligned Multipass Cavity



**Mirror spacing determines the inter-pulse interval to match to 2.8ns**

**Slight mirror tilt from perfect auto-collimation or slight shear of one lens gives scanning with equally spaced foci and a controllable spacing**

**PC gate switches pulse into cavity**

**Need to keep round-trip losses very low to ensure sufficient passes at sufficient power**

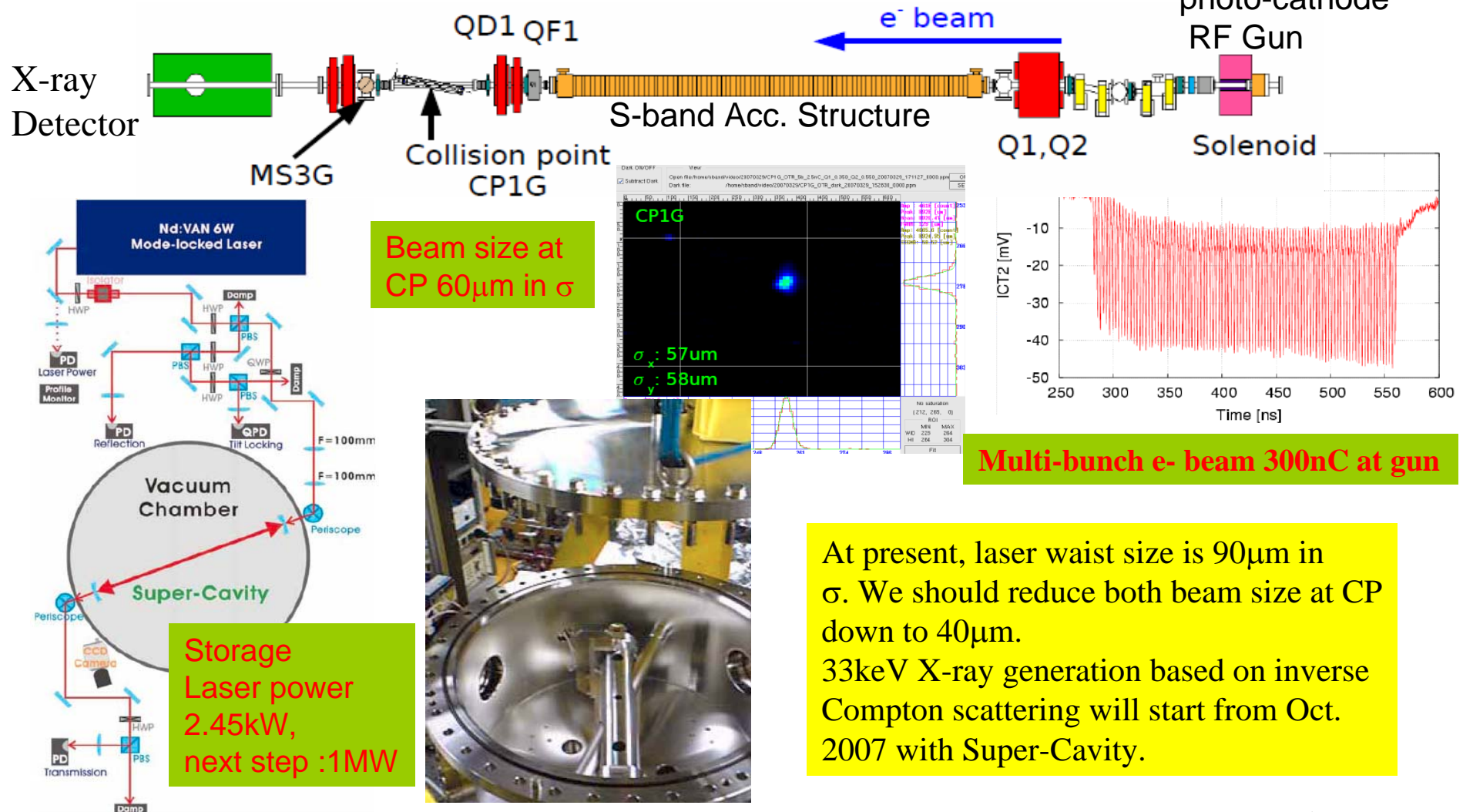
**Other designs possible**

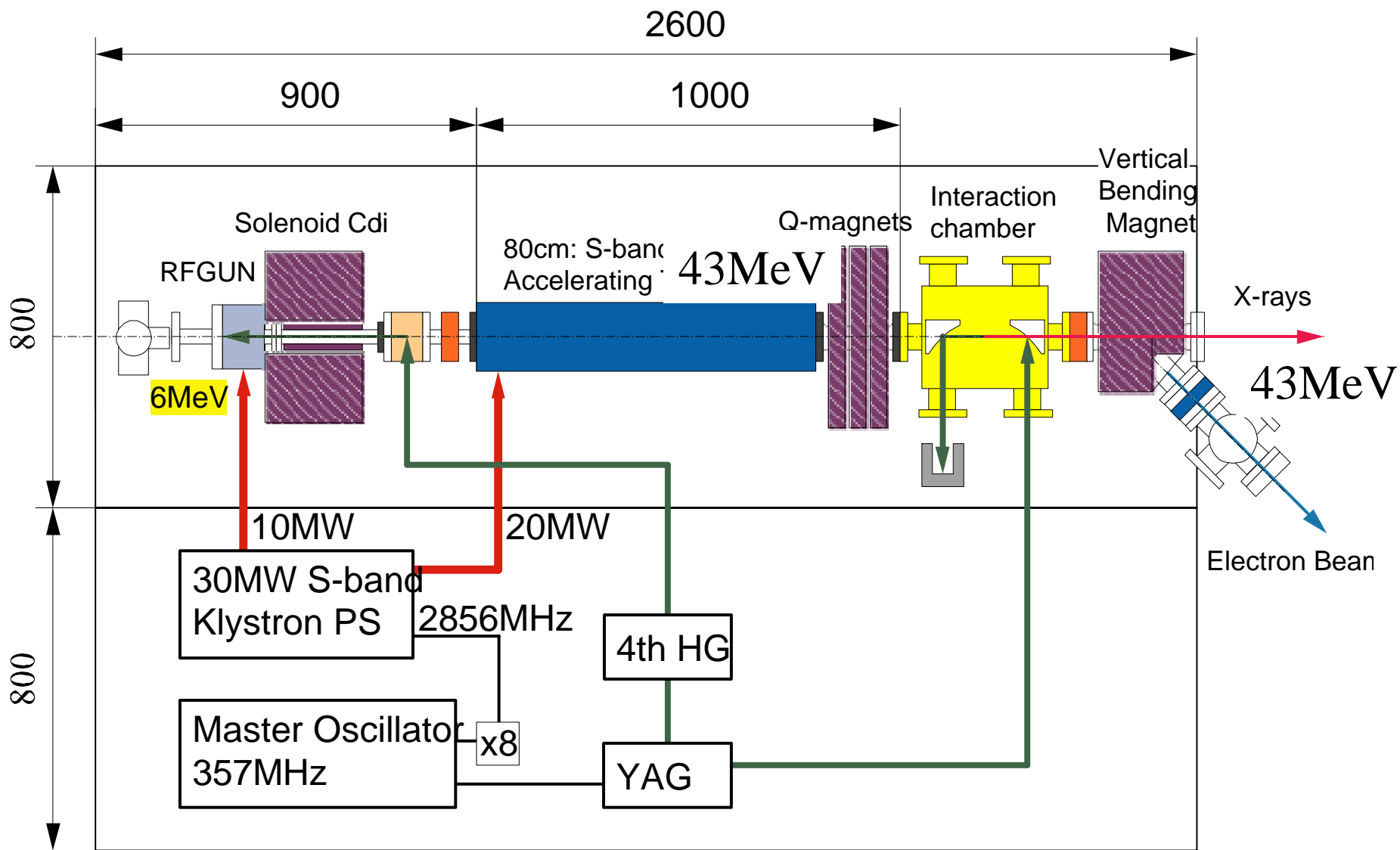


# Laser Undulator Compact X-ray (LUCX)

## Project at KEK-ATF

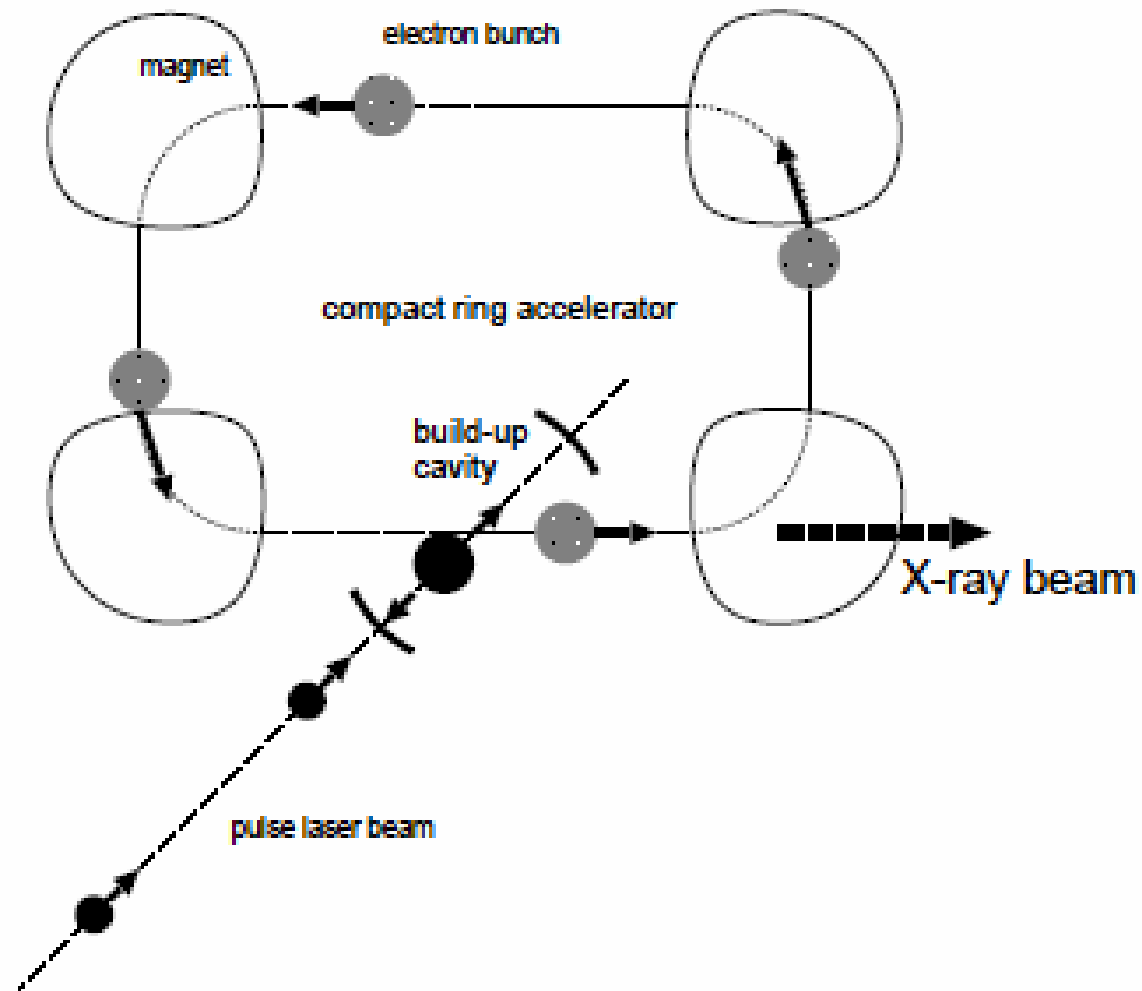
**43MeV Multi-bunch beam+ Super-Cavity = 33keV X-ray.**





開発装置概念図





$>10^{13}$  photons/sec,  $>33\text{keV}$ , 1% energy spread  
 小型高輝度X線源開発(周長10m程度)と実用化が目標。